

In re the Application of:

HIROYAMA, Ryouji et al.

Group Art Unit: 2815

Serial No.: 09/669,448

Examiner: Matthew C. Landau

Filed: September 25, 2000

P.T.O. Confirmation No.: 2968

FOR: SEMICONDUCTOR LASER DEVICE AND METHOD OF MANUFACTURING

THE SAME

AMENDMENT AFTER ALLOWANCE UNDER 37 C.F.R. 1.312

MAIL STOP ISSUE FEE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

April 9, 2004

Sir:

Applicants received a Notice of Allowance dated March 26, 2004 in connection with the above-identified application. It is respectfully requested that the following amendment be made to claim 2 of this application: